PATEN1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Eun -Kyung Lee

Conf. No.:

5019

Application No.:

10/758,136

Examiner:

Laura M. Schillinger

Filing Date:

January 16, 2004

Art Unit:

2813

METHOD OF MANUFACTURING SILICON

OPTOELECTRONIC DEVICE, SILICON

Title:

OPTOELECTRONIC DEVICE MANUFACTURED BY THE

METHOD AND IMAGE INPUT AND/OR OUTPUT

APPARATUS USING THE SILICON OPTOELECTRONIC

DEVICE

Attorney Docket:

2557SI-001230/US/CPA

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314

Mail Stop Amendment

October 9, 2009

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir/Madam:

In response to the Office Action mailed September 20, 2005, the following amendments and remarks are respectfully submitted in connection with the aboveidentified application.

Amendments to the Specification begin on page 2 of this paper.

Listing of the Claims begin on page 3 of this paper.

Remarks begin on page 10 of this paper.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	35	-	35	н	0
Independent	2	-	3	11	0